European Network on New Sensing Technologies for Air Pollution Control and Environmental Sustainability - *EuNetAir* COST Action TD1105 2nd International Workshop *EuNetAir* on *New Sensing Technologies for Indoor and Outdoor Air Quality Control* ENEA - Brindisi Research Center, Brindisi, Italy, 25 - 26 March 2014

CMOS-BASED SENSORS FOR UBIQUITOUS GAS DETECTION: CHALLENGES AND OPPORUNITIES



WWW.CCMOSS.COM

Dr. M F Chowdhury, Prof. F Udrea, Prof. J.W.Gardner, Dr. S.Z.Ali & S. Stacy Function in the Action (WG Member – Prof. F. Udrea) mohamed.chowdhury@ccmoss.com or florin.udrea@ccmoss.com United Kingdom

Contents

- About Cambridge CMOS Sensors
- Global Sensor Market
- Ubiquitous Sensors Market Focus
- Need for Ubiquitous Gas Sensors
- Current Technology



About Cambridge CMOS Sensors

Established in 2008, Spin-out from Cambridge University & University of Warwick (seed funded by Cambridge Enterprise)

Strong Patent portfolio in CMOS MEMS Micro-hotplates and sensors for ubiquitous applications

Key Product Focus:

•Ultra-low power gas sensors for mass-market application
•Micro-Hotplates for resistive gas sensing applications
•Broadband Infrared Sources for a range of infrared based sensors
•High Performance Infrared detectors

The founders, Prof. Florin Udrea (Cambridge), Prof. Bill Milne (Cambridge) and Prof. Julian Gardner (Warwick) CEO: Nat Edington (Previously at Wolfson Microelectronics) Currently: 17 employees -> 20 to 25 Q4 2014





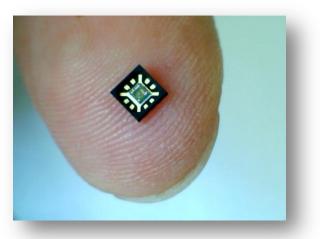


Core Technology: Micro-hotplate

What is a Micro-hotplate?



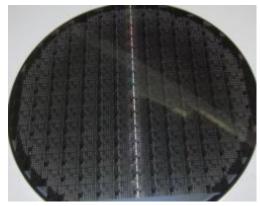




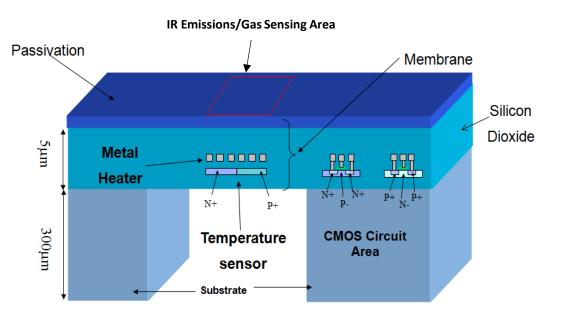
Well it is like an electric cooker, but we have integrated on a silicon chip! You can have about 10K of these hotplates on a single 6" wafer!

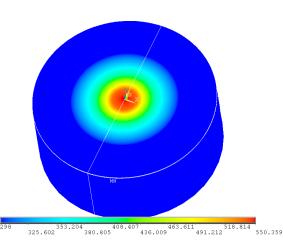
As we know heat is a source of everything!





Technology Breakthrough





0.0

101.0

202.0 Temperature (*C)

Successfully integrated micro-hotplate on standard CMOS process and enabled:

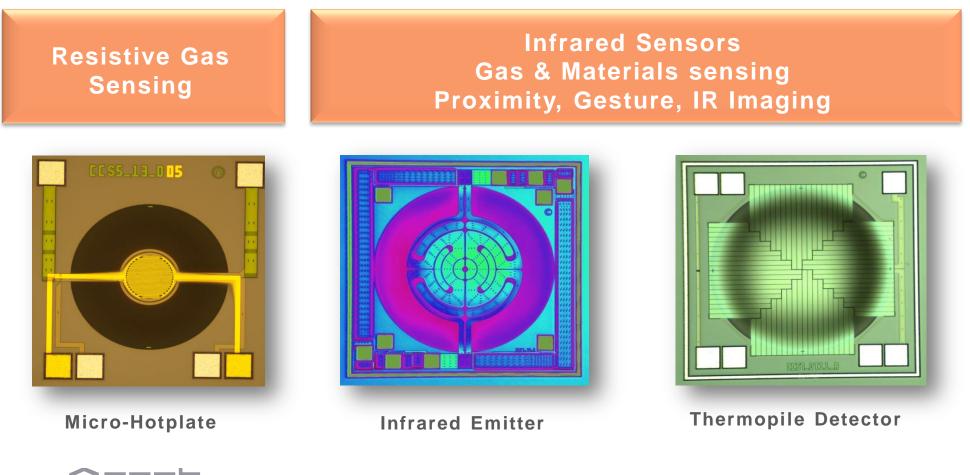
- •High Temperature
- High stability
- High reproducibility
- •High reliability
- Preparatory know-how and strong patent portfolios



302.9

Products & Applications

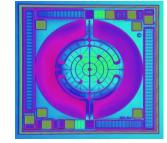
Technology offers wide range of applications

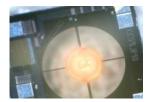




Key Benefits

- Ultra-low power consumption
 - μW average for gas analysis
- Fast thermal transient response
 - 20ms thermal transitions to max temp
- Cost-effective and high volume manufacturing
- Miniaturised system
 - 100μm diameter hotplates or smaller!
- Broadband IR Emissions longer wavelength IR applications
- Improved reliability and stability
- On-chip integration of drive and signal processing electronics for a "system-on-a-chip" solution.







Array of MHP on 1mm x 1mm die.



Sensor Applications

Non-Dispersive Infrared Sensors (NDIR)

- CCMOSS Broadband IR Sources enable detection of a wide range of gases
- Optical IR sensing using gas absorption

Resistive Gas Sensors

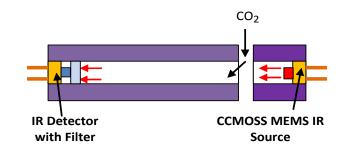
- Enabling single or multi-gas sensing with CCMOSS Micro Hotplate single die, or die arrays
- Detection of gases through catalytic reactions on sensor surface causing resistance changes

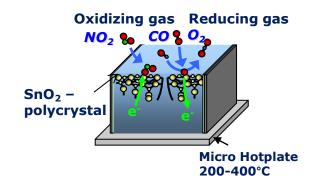
Attenuated Total Reflectance (ATR) Sensors

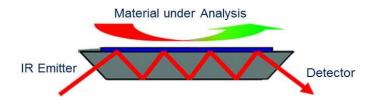
 CCMOSS IR Sources enable Miniature sensors for detection & analysis of gels, liquids, solids (powder)

Miniature proximity sensors

 CCMOSS Mid-IR Sources & Detector arrays enabling Motion detection & Gesture control

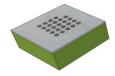






Examples of Current Products

Sensors



Gas Sensors

Product	Description	Power Consumption ^{1 2}	Heat Resistance	Heater Voltage	Package
CCS801	Ultra-low power multi-gas sensor for air quality monitoring	~0.12 - 0.23mW	50Ω ± 10%	0.87 - 1.27V	SMD 3x2mm
CCS802	Ultra-low power gas sensor for monitoring carbon monoxide	0.12mW	48Ω ± 10%	0.87V ± 0.05V	SMD 3x2mm
CCS803	Ultra-low power gas sensor for monitoring ethanol	0.18mW	47Ω ± 10%	1.1V ± 0.05V	SMD 3x2mm

	Product	Description	Powe Cons	er sumption ¹	Heat Resi	t stance	Heat Area		Heate Volta		Frequency ²
	CCS101	Ultra-low power IR source device	72m\	W±5mW	80Ω	± 25%	0.05 MIN	mm²	2.4V	± 0.3V	70Hz
	CCS102	Low-power IR source device	160m	nW ± 15mW	33Ω	± 25%	0.28 MIN	mm²	2.3V	± 0.2V	36Hz
IR Emitters	CCS103	Low-power IR source device	140m	nW ± 15mW	21 <u>Ω</u>	± 25%	0.5m	1 m² MIN	1.7V	± 0.2V	30Hz
	CCS104	High-output IR source	500m	nW±50mW	9Ω ±	25%	3.0m	m² MIN	2.1V	± 0.2V	16Hz
	Product	Description		Power Consumption ¹		Heat Resistance		Heater Voltage		Diode Te Coefficie	· · · · · · · · · · · · · · · · · · ·
Micro-hotplates	CCS301	High-temperature MEMS micro hotplate	D-	72mW ± 5mW		80Ω ± 25%		$2.4V \pm 0$).3V	1.3x 10-	3 V/K



Global Sensors Market

Global Sensor Market predicted to grow from \$62B (2011) to \$92B (2016)*

Key growth markets - Automotive, Consumer Products & Medical healthcare

Sensor Market driven by 4 Key Technology Trends

- Lower Cost
- Lower Power
- Smaller
- Wireless Connectivity







* Sensors: Technologies and Global Markets, BCC, March 2011



Market Focus

Consumer(\$22B: 2015***)

- Smartphone Ambient Air Quality Monitoring
- Gesture-based Interfacing, Zero Touch Technologies
- Personal Sports monitoring

Medical/ Home Healthcare (\$12.5B: 2015**)

- Personalised healthcare monitoring
- Breath Analysis for diagnosis

Automotive(\$14B: 2011*)

- In-Vehicle AlcoLocks for alcohol detection
- In-Vehicle Air Quality
- Emissions Testing & Monitoring

Domestic & Industrial Security (\$7B: 2011+)

- Refrigerant leak detection
- Fire Detection
- Ambient Air Quality Monitoring



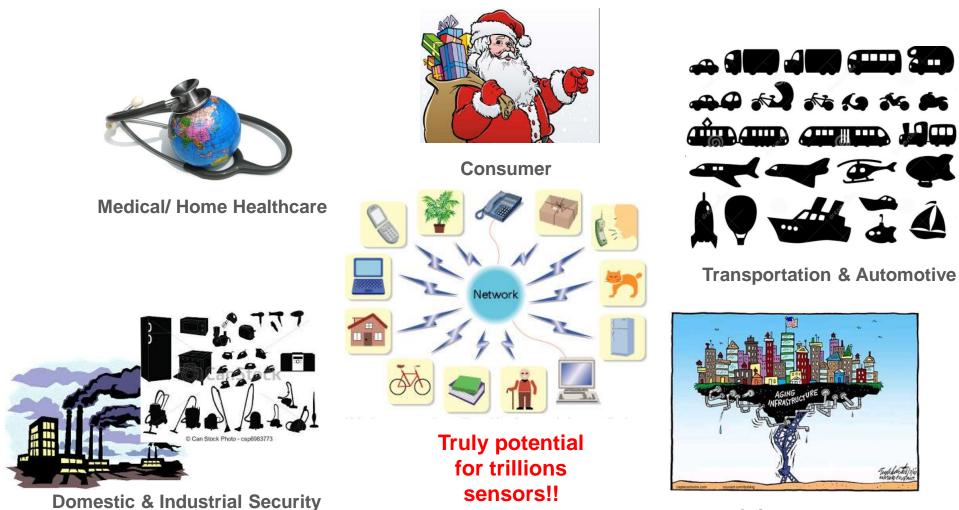
* Strategy Analytics, 2011 **Frost & Sullivan, 2010 ***MarketsandMarkets, 2010 *Decision, 2007 + CCS Estimates







Meaning of Ubiquitous



Infrastructures

ANYWHERE, ANYTIME, BY ANYONE AND ANYTHING

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Trillion Sensors Summit (Oct 2013)

Introduction to TSensors and TSensor Systems

Dr. Janusz Bryzek, VP Development, MEMS and Sensing Solutions, Fairchild Semiconductor

While in 2007, 10 million sensors were absorbed, in 2012 the MEMS sensor absorption in mobile devices grew to 3.5 billion sensors, representing about 220%/y compounded growth rate.

As sensors are becoming part of global problem solutions ... sensor volumes to exceed trillions by 2022. .. drive semiconductor to \$2 trillion.

Overcoming Systems Hurdles for a Trillion Sensor World

... trillion sensors could overwhelm current internet capability

... more viable system level energy efficient solutions like self or low power sensor will have to be the norm in a ubiquitous sensing world.

TSensor Systems is developing three focus groups:

- 1. Sensor technology
- 2. Data transmission technology
- 3. Data processing technology

Marketing Evolution Enabling TSensors Revolution

Sensor-based Revolution to Change Redistribution of Global GDP, Vijay Ullal, President, Fairchild Semiconductor

Countries with fastest adoption of sensors based systems are likely to free the largest number of people for creative work, thus start dominating the global economy.

http://www.tsensorssummit.org/Resources/TSensors%20Summit%20Abstracts.pdf

Trillion Sensors Summit

Digital Health to Drive Trillion Sensors

Monitoring Environment to Stay Healthy, Sywert Brognersma, IMEC

High Sensitivity Multigas sensors for Air Quality Monitoring and Breath Analysis

Sensory Swarms/Internet of Things and Everything

 3D Printed Smart Systems
 Phase 1: Development of a visionary 10 year market forecast ,, \$1T by 2023

 Mobile and Wearable Market
 Phase 2: The collected emerging sensor applications will be split into number of categories

 Just Make It
 Phase 3: Based on the above, we plan to form working groups to make a recommendation

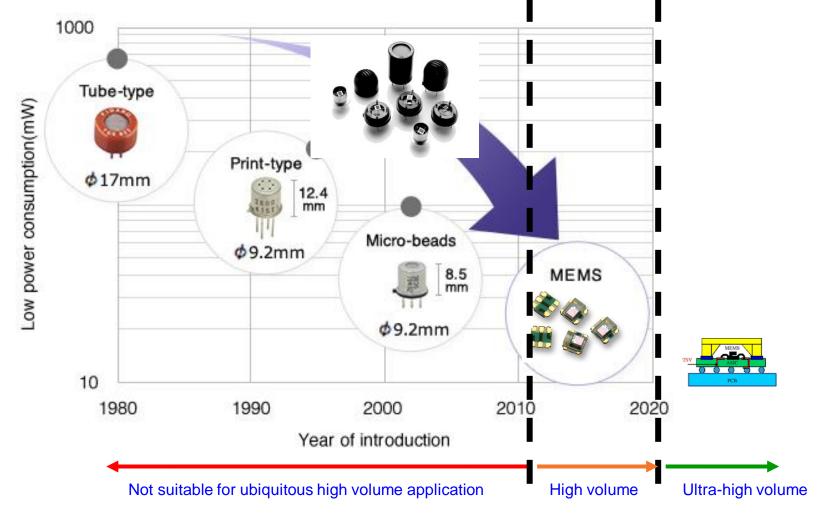
Sean Stetson, TPL - Advanced Technology and Products Group, Motorola Mobility One of the biggest challenges we face as a Nation is the decline in our ability to make things. Americans today consume more goods manufactured overseas than ever before. ... This decline has a severe impact on the Nation's economic vitality and security; because quite simply, to innovate, we must make. **Same story is for EU.**

Applications and required infrastructure to support a trillion sensor market Jean-Christophe Eloy, President and CEO, Yole Développement, France

.... sensor designs are not currently adapted to support a higher growth



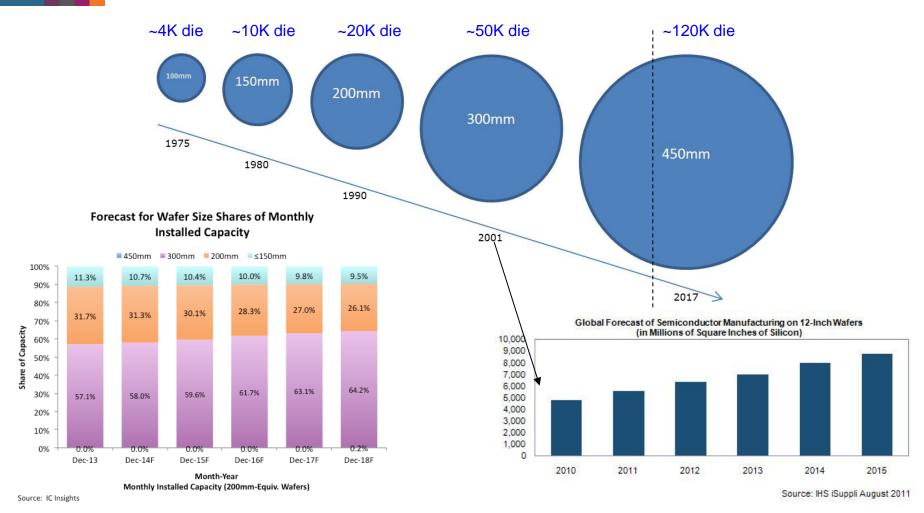
Reason for New Generation of Gas Sensors



Courtesy Figaro for the base graph

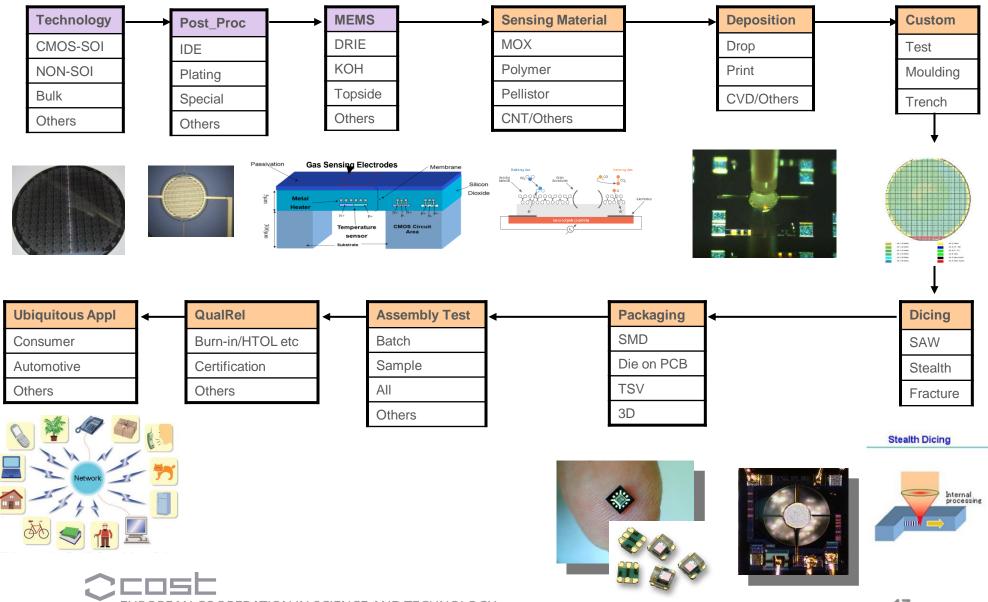


CMOS Enabling True Ubiquitous Sensors



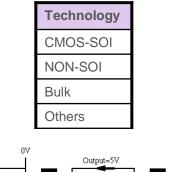
Silicon is the material cheap high-quality materials and with electronic functionality makes it attractive for a wide variety of MEMS applications. In single crystal form, silicon is an almost perfect - when it is flexed there is virtually no hysteresis and hence almost no energy dissipation. As well as making for highly repeatable motion, this also makes silicon very reliable as it suffers very little fatigue and can have service lifetimes in the range of billions to trillions of cycles without breaking.

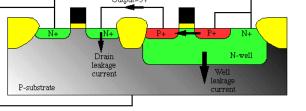
Towards Ubiquitous Sensors Manufacturing

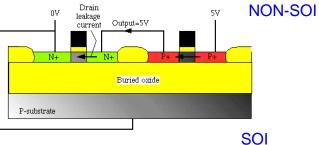


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Challenges: Technology







- Silicon foundry must offer high temperature metallisation
- Offer ALL post-CMOS services at the foundry
- Provide adequate volume capacity
- Competitive cost per wafer
- Process migration
- High yield > 95%

Bulk is just metals - without CMOS

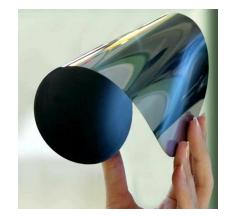
Bulk + Flexible



5V

Opportunities: Technology

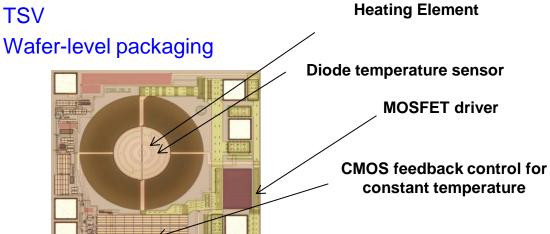
Technology
CMOS-SOI
NON-SOI
Bulk
Flexible



300mm, 50µm thick silicon wafer!

- Process migration larger wafer ٠
- **Further miniaturisation** ٠
- Bring some post-CMOS steps and part of CMOS ٠
- Smart sensor Lab-on-chip ٠
- Wafer thinning ٠
- **TSV** ٠

٠



Cost reduction: SOI -> NON-SOI -> Bulk -> Plastic(?)

Challenges: Post-CMOS Processing

Post_Proc
IDE
Plating
Special
Others



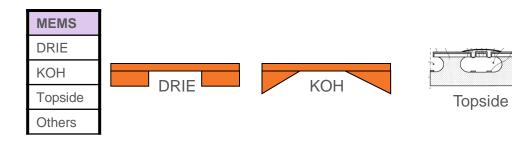
- Interdigitated Electrodes (IDE)
- Plating of IDE
- Surface processing for adhesion
- Reproducibility
- Reliability
- High temperature capability
- High yield >95%

Opportunities: Post-CMOS Processing

- Multi-sensing platform
- Novel designs
- Nano-material platform
- High volume production capabilities

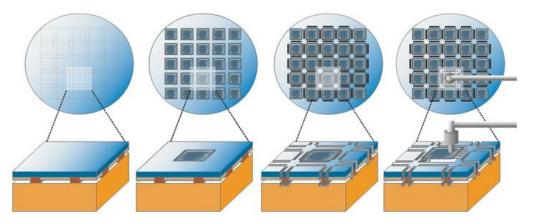
EUROPEAN COOPERATION IN SCIENCE AND TECHNOLOGY

Challenges: MEMS Processing



- DRIE at commercial foundry
- Accuracy
- Reproducibility
- High yield > 95%
- Migration

Opportunities: MEMS Processing



- DRIE offers compact arrays
- Further miniaturisation
- Top-side and back-side etch
- 3D Packaging
- TSV
- Eliminate dicing trench

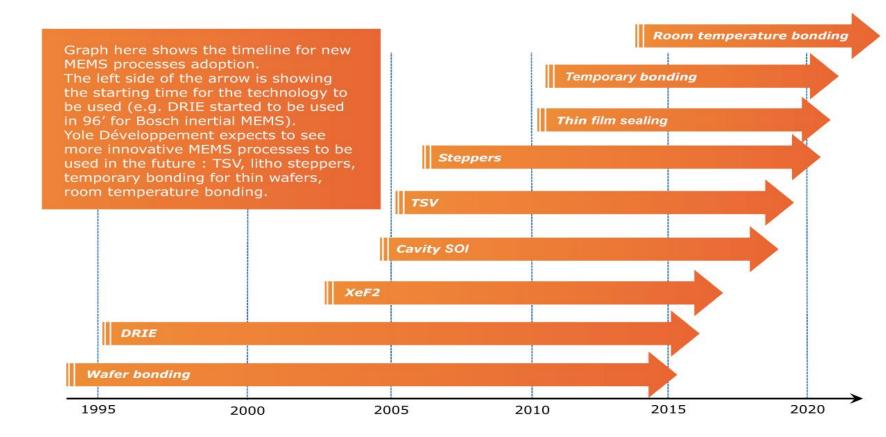
Both CMOS & MEMS done at the same commercial foundry (Some sensors may not require MEMS, but CMOS platform still enables ubiquitous capability with on-chip circuits)

(Example DRIE machine)

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MEMS Roadmap





⁽Yole Développement, February 2013)

Challenges: Sensing Materials

Sensing Material
MOX
Polymer
Pellistor
CNT/Others

- Expertise
- Type of material
- Sensitivity & selectivity
- Reproducibility
- Reliability
- High temperature capability
- High yield >95%

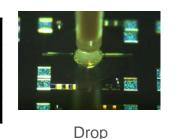
Opportunities: Sensing Materials

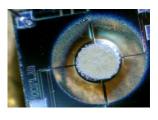
- CNT and Graphenes
- Innovation
- Multi-sensing + Redundancy
- CMOS process integration

CCMOSS is actively involved in FP7, EU project (GRAFOL) helping to enable this capability!

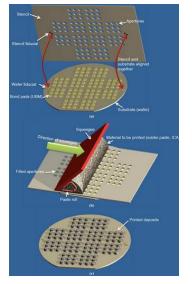
Challenges: Sensing Materials Deposition

Deposition
Drop
Print
CVD/Others





CVD/Other



- Coating
- Composition
- Sintering
- Adhesion
- Controlled thickness
- High volume production
- Fragile surface
- High yield >95%
- New tooling

Print

Opportunities: Sensing Materials Deposition

- Develop process at CMOS level
- Other method
- Improved Yield
- Process control
- New tooling

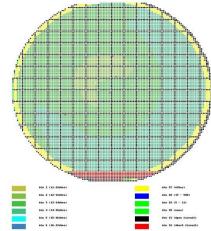


Wafer-level Test

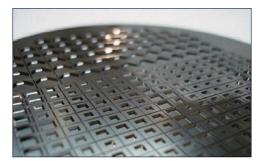
Custom

- Test Moulding Trench
- Fully-automatic probe tests
- Heater resistance measurements
- Sensing parameter measurements
- Power consumption
- Optical Test





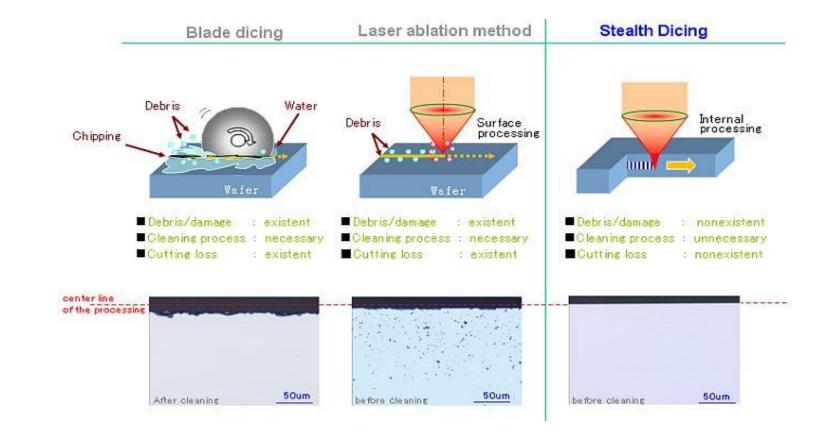
- Wafer map showing results of wafer level test
- Yellow edge dice are not etched under emitter
- >99% yield to spec
- MANUFACTURABLE IN HIGH VOLUME!



Wafer-level moulding



Dicing



If dicing can be eliminated then significant cost advantage can be achieved!



Dicing

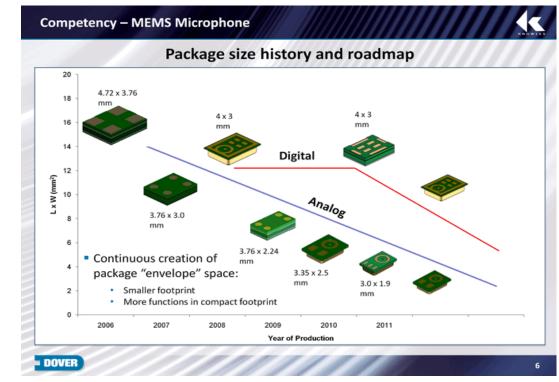
Fracture

SAW Stealth

Packaging

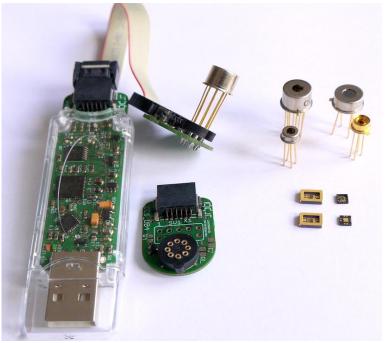
- Die exposed
- Environmental protection
- High volume

- Small form factor
- Low cost
- High reliability

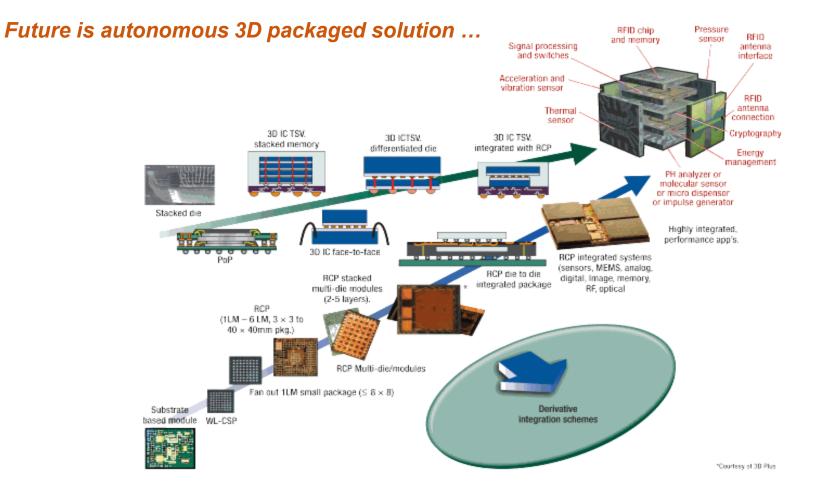


- Through hole
- SMD
- Die on PCB
- 3D TSV

Packaging
SMD
Die on PCB
TSV
3D



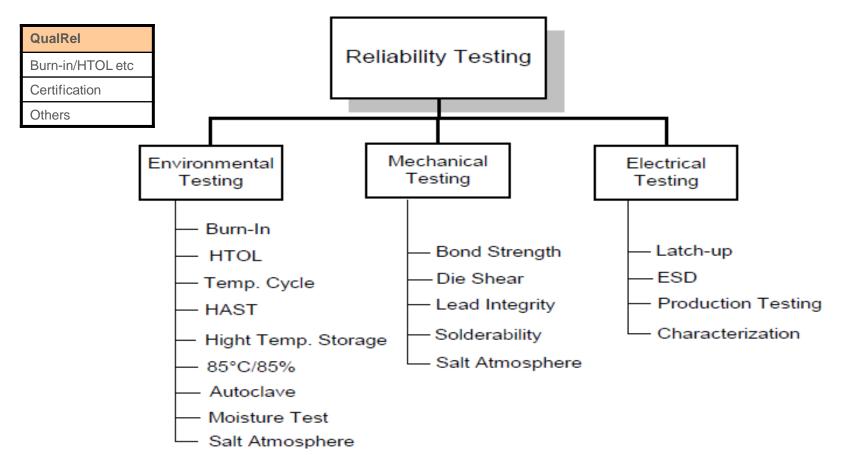
Packaging Opportunities



CCMOSS is actively involved in FP7, EU project (MSP) helping to enable this capability!



Qualification and Reliability

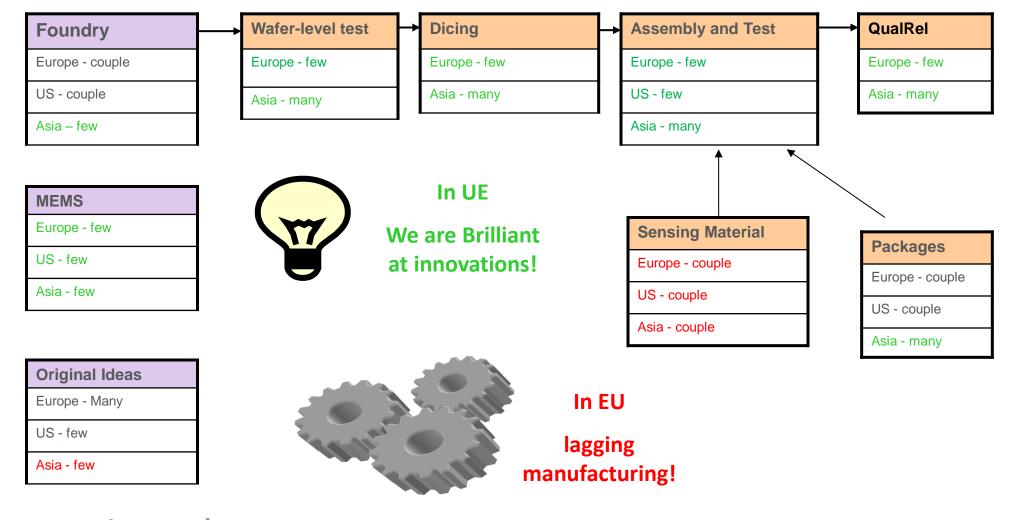


We need local cost-effective quick turn-around solutions!

CCMOSS is actively involved in FP7, EU project (SOIHITS) helping to enable this capability!



EU Manufacturing Scenario





Conclusions

- CCMOSS has built know-how to enable ubiquitous gas sensing
- Working with leading partners for high volume production capabilities
- High volume production turnkey in place
- For high manufacturing establish global partnership
- More challenges and opportunities are created for diverse sensing application – not just gas sensing.



Acknowledgements

CCMOSS Team









Investors

